## PATENT APPLICATION

## RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 1762

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA Group Art Unit: 1762

Application No.: 10/827,317 Examiner: J. LIN

Filed: April 20, 2004 Docket No.: 119294

For: PATTERN FORMATION METHOD, DEVICE MANUFACTURING METHOD,

ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the October 18, 2006 Office Action, please consider the following:

Amendments to the claims as reflected in the listing of claims; and

Remarks.